

Practitioner's Docket No.:

L&amp;L-I0242

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Laurence A. GreenbergFebruary 14, 2006  
DateIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/694,593 Confirmation No.: 3503  
Applicant : Olaf Storbeck, et al.  
Filed : October 27, 2003  
Title : Method for Minimizing the Vapor  
Deposition of Tungsten Oxide During the  
Selective Side Wall Oxidation of  
Tungsten-Silicon Gates  
Art Unit : 2823  
Examiner : Fernando L. Toledo  
Customer No. : 24131

PRELIMINARY AMENDMENT

Mail Stop Non Fee Amendment  
Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

S i r :

Responsive to the Advisory Action dated January 24, 2006 and further responsive to the Office action dated October 14, 2005, kindly amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.